

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of ) **MAIL STOP PETITIONS**  
Nathan S. Lewis )  
Application No.: 09/905,157 ) Group Art Unit: 2813  
Filed: July 12, 2001 ) Examiner: COLLEEN E. RODGERS  
For: ELECTRICAL PASSIVATION OF ) Confirmation No.: 2732  
SILICON-CONTAINING SURFACES ) Certificate of Electronic Deposit  
USING ORGANIC LAYERS ) I hereby certify that this correspondence is being  
 ) deposited with the United States Patent & Trademark  
 ) Office on August 25, 2008 via EFS-Web.  
 ) By: \_\_\_\_\_ /Joseph R. Baker, Jr./  
 ) Joseph R. Baker, Jr.  
)

**AMENDMENT/REPLY TRANSMITTAL LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed is a Petition with Withdrawal Abandonment or in the alternative a Petition to Revive an Unintentionally Abandoned Application.

- Also enclosed is/are: Petition, Substitute Drawings, Request for Withdrawal of Abandonement
- Small entity status is hereby claimed.

Respectfully submitted,

GAVRILOVICH, DODD & LINDSEY LLP

Date August 25, 2008

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